

# A microfluidic strategy for accessing the thermal conductivity of liquids at different temperatures

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1	A microfluidic strategy for accessing the thermal conductivity of liquids at different					
2	temperatures					
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8						
9	Highlights:					
10	• Microfluidic device providing thermal and mechanical resistance to temperatures up t	:0 60				
11	°C.					
12	• Measurement of thermal conductivity for various chemical families with an accuracy from	n 2%				
13	to 8%.					
14	• New experimental values for 2,5-dimethylfuran for which there is scarce the	ermal				
15	conductivity data information in the literature.					

#### 16 Abstract:

17 Biomass-based biofuels represent a promising alternative fossil energy source, for which conversion processes - mostly performed at high pressure and temperature conditions - require thermophysical 18 property data, particularly thermal conductivity. Conventional methods to measure thermal 19 20 conductivity are often time consuming and/or need important quantities of products. Microfluidics 21 has been proven to be a viable solution to these issues thanks to its low reagent consumption, fast 22 screening capabilities, improvement of heat and mass transfers etc. However, microfabrication 23 materials used in previous works, do not exhibit sufficient chemical inertness, nor thermomechanical 24 properties to apply such methods to large ranges of fluids systems and conditions. Here, we develop 25 new microreactors including sensors integrated into microfluidic channels with an operating principle based on the transient thermal offset approach for thermal conductivity measurement, built with 26 27 materials commonly used for microreactors operated in harsh conditions. The sensor calibration is performed on water/ethanol mixtures and externally validated for two fluids: n-pentadecane and 28 29 ethan-1,2-diol along with the evolution of their thermal conductivity with temperature. Finally, the microfluidic device is used to generate thermal conductivity data for 2,5-dimethylfuran, a biomass-30 based compound with high potential as biofuel and for which experimental data has not been 31 32 reported so far.

33 Keywords: Micro-sensor; Microfluidics; Thermal conductivity; Temperature

#### 34 **1. Introduction**

The thermal conductivity ( $\lambda$ ) of liquids is an essential thermodynamic data for the technical design of 35 many processes. For instance, transport properties involving mass and heat transfers are widely 36 37 considered in industrial applications such as separators, reactors, or even heat exchangers. The 38 conversion of biomass into useful forms of energy (e.g., biofuels) represents a promising alternative to fossil resources. In the case of aircraft, the fuel itself serves as the primary heat transfer medium 39 40 in the thermal management systems. Thus, fluid's thermal conductivity is an important 41 thermodynamic data to consider when designing and developing processes that will produce 42 alternative fuels.

43 There are various experimental techniques available for the measurement of thermal conductivity, 44 the transient hot-wire method is regarded as one of the standard macroscopic techniques for fluid samples [1,2]. This technique is based on monitoring temperature changes of a thin metallic wire. 45 46 The wire and then the surrounding liquid begin to heat up when applying a constant electric power. The thermal conductivity of the surrounding liquid can be determined by recording the temporal and 47 48 spatial evolution of the corresponding temperature response. Two components can be used to monitor temperature changes: a heater, which is made of a resistive metal wire or film, and 49 thermocouples, which are used for temperature sensing [3,4]. Nevertheless, due to the low thermal 50 conductivities of liquids in comparison with solids or metals, the thermocouple must be placed very 51 52 close to the heating element, or the duration of the measurements must be sufficiently long, both of which are challenging to implement. Another solution to monitor temperature changes is by 53 considering the variation of the electrical resistance of the wire or film in contact with the fluid. The 54 55 wire or film can be used in this case, both as heating element and temperature sensor as already proposed Gustafsson et al. [5–7]. Instead of a wire, other geometries such as thin metal sheets; as 56 the transient hot strip (THS) method [5] or double spirals with insulating materials have also been 57 implemented such as transient plane source (TPS) method [8]. The TPS method uses a geometry with 58 59 higher surface contact than the hot strip or hot wire method, which are also more fragile, and temperature measurements can be performed with greater sensitivity and accuracy. Besides transient methods used to determine the thermal parameters there are approaches based on harmonic (sinusoidal) excitation called the  $3\omega$  method [9]. However, this technique requires supplementary instruments which can be costly, as well as complex installations for the measurement.

However, due to convection and radiation that accompany heat losses, it is challenging to precisely determine thermal conductivity using these methods with large equipment; therefore, using smaller scales volumes would limit these issues. Thus, milli or microfluidics have been shown to be interesting approaches for such measurements [10–12]. Besides being smaller, lighter, and cheaper than conventional instruments, microfluidics can greatly reduce the measurement times along with reduced reagent consumption, resulting in a significant financial and industrial impact specially when fluid sample is costly or scarcely available.

72 Several microfluidics based methods were proposed including separated heating element such as a 73 laser which uses localized heating source along to reduce undesired heat loss [13] and temperature sensor such as miniature thermocouples [13–15]. The resistive element in microtechnology, is a thin 74 75 film structure deposited on a substrate with known thermal properties. As a result, the use of MEMS 76 (MicroElectroMechanical Systems) has enabled the adaptation of traditional methods to determine thermal conductivity at micro-scales. Therefore, it was already reported that the thermal 77 78 conductivity can be measured using a single resistive element that acted as both heater 79 and temperature sensor, such as the hot-strip method [16,17] or the  $3\omega$  method [18,19], for which 80 the sensor implemented is simpler to fabricate.

Oudebrouckx et al. reported the use of micro-scale devices to predict the thermal conductivity of fluids [20]. The authors used aluminium as a highly thermally conductive material that acted as heat sink to eliminate uncertainties encountered in micro-scale systems. The bottom of the device was made of polyimide, an electrically insulating substrate, with a metal resistive heating structure. The term "thermal penetration depth" refers to the distance that the heat flux travels through the

material from any point on the thin metallic film's surface [3,21]. When working with small liquid 86 87 samples, thermal depth issues frequently cause additional measurement errors. They deliberately 88 applied thermal pulses that exceeded the liquid's physical boundaries inside the microchannel, while staying within the limits of the aluminum top reference. As the top reference material has a much 89 90 higher thermal effusivity than the substrate and fluid, the heat dissipated by the sensor structure is 91 absorbed, ensuring a constant temperature increase rates for all subsequent measurements. The 92 thermal conductivity of fluids from transient curves can be calculated using simple data analysis. 93 However, only a few fluids have been experimentally measured in the cited works, and some of the 94 considered microfabrication materials exhibit limited chemical compatibility and are only suitable for 95 room temperature measurements. The temperature dependence of fluid thermal conductivity has only been documented in a few studies that only measured one fluid (DI water) [22,23]. 96

97 The silicon-borosilicate microfluidic technology [24] has become popular over the past decade as it 98 allows extending the range of operating conditions compared to conventional microfluidics 99 materials. This characteristic has opened the microfluidic fields of research to materials synthesis 100 [25], chemistry in harsh conditions [26], geosciences [27,28] and particularly for determining the 101 thermo-physical properties of fluid systems under pressure and temperature [10,27]. This technology 102 is beneficial for real-world applications, especially in industrial settings. Therefore, we propose the 103 development of a new microfluidic device that allows to determine thermal conductivity for various 104 chemical families and different temperature conditions up to 60°C.

In this paper, we demonstrate the use of silicon-borosilicate microreactors equipped with thin film sensors to measure the thermal conductivity of several fluids in the range 20-60°C. We first detail briefly the fluids and materials used, the conception of the microfluidics device, the overall measurement setup, the readout device used to measure fluid's thermal conductivity, and the measurement procedure. Then, the obtained results are discussed, including the microdevice calibration on microliter-sized samples of water/ethanol mixtures, the validation measurements performed on well-known fluids (n-pentadecane and ethan-1,2-diol), and the acquisition of new

- experimental data for 2,5-dimethylfuran, which is one typical product issued from the conversion of
   biomass. Further developments and perspectives are finally discussed.
- 114 **2.** Materials and methods

#### 115 **2.1. Chemicals and materials.**

Mixtures of ethanol/ water were made using absolute ethanol (99.8%) and distilled water. The fluids selected for thermal conductivity measurements: ethanol, ethan-1,2-diol, n-pentadecane, with high purity grades, were purchased from Alfa Aesar, and 2,5-dimethylfuran from Sigma Aldrich.

Silicon wafers (1 mm thick, diameter: 4 inches) covered with a silicon oxide ( $SiO_2$ ) layer of 500 nm thickness, as well as Pyrex<sup>®</sup> (borosilicate glass, 1.5 mm thick, diameter: 2 inches) were used for the

121 conception of the microfluidic chip.

Buffered oxide etchant (BOE) and a tetramethylammonium hydroxide solution (25 wt. % in H<sub>2</sub>O) were purchased from Sigma Aldrich. MICROCHEM remover PG N-Methyl-2-pyrrolidone (NMP) based solvent was provided by Fisher Scientific.

Commercial targets from Neyco (diameter: 2 inches and thickness: 3mm) of Chrome and Platinum with purities of 99,997 % were used for the Magnetron-sputtering deposition of the sensors on the Pyrex wafer.

128

## 2.2. Microfluidic device fabrication.

The microfluidic device including sensors integrated into microchannel was fabricated following a three-step procedure. First, microchannels were etched on a silicon substrate using photolithography and wet etching techniques, as previously described [24]; then, the sensors were created on a borosilicate glass substrate surface by selectively depositing a structured metallic film patterned according to the microchannels features; finally, the silicon and borosilicate glass substrates were assembled using a fusion bonding process resulting in the final microfluidic device. These procedures are detailed in the Supporting Information ESI-1 section.

136 Choice of microchannel and sensor geometry. The microchannels and sensors were designed using 137 the AutoCAD<sup>®</sup> software and printed on flexible photomasks. As shown in Figure 1, the main microchannel is 200 μm wide and 60 μm deep, the measurement micro-pool has dimensions of 2 mm x 3 mm. This design enables the micro-pool to encompass the sensor, allowing the fluid to completely cover it. Spiral shape was chosen due to its high surface contact, uniform thermal distribution, and high resistance, resulting in lower power consumption [29]. The spiral shaped metal structure has a 2 mm diameter with 6 concentric rings, each having a width and spacing of 50 μm and 100 μm, respectively. The fabricated microfluidic device is illustrated in Figure 1.



Figure 1: Illustration of the dimensions and geometries for a) the microchannel part: red dotted rectangle represents a zoom of the microchannel (micro-pool), green dotted rectangle represents the cross-section microchannel's trapezoidal geometry and b) sensor part: blue dotted square represents a zoom of the spiral shape metallic structure, c) illustration of the final microfluidic device

The scheme of its cross-section is proposed in Figure 2. The bottom part of the device consists in a thermal/electrical insulator (borosilicate glass substrate) on which a Pt thin film spiral planar heating structure is present. The top of the microchannel is made of a thermal conductor top reference (silicon substrate). Due to its high thermal conductivity, silicon was specifically chosen. This device is conceptually advantageous due to its chemical inertia, the ability to work at higher temperatures and optical access for coupling to other *in situ* characterization.



Figure 2: A schematic cross-section of the microfluidic cavity designed for measurements of fluids  $\lambda$ . Heat transfer generated by metallic spiral is represented by red arrows.

The as-obtained microfluidic device must be then connected to the experimental environment through a compression piece "holder" [30]. The electric interfaces are connected via square contact pads on both ends of the heater, and the temperature is monitored using a K-type thermocouple (probe diameter = 0.3 mm) placed in-between the holder and the microfluidic device, as detailed in the Supporting Information ESI-2 section.

155

## 2.3. Thermal conductivity measurement

A Wheatstone bridge was used in the  $\lambda$  measurement system [31–34] to monitor the electrical resistance variation of the thin Pt spiral sensor. When the bridge is balanced, small voltage variations can be translated into temperature variations, as discussed further below.

Description of the set-up. The schematic measurement system (available in Supporting Information 159 Figure ESI-3-1) consists in a DC power with constant voltage supplied by a generator from RS Pro 160 model RS6005P. The Wheatstone bridge consists in two precision resistors:  $R_1 = R_2 = 465.8 \Omega$ , with 161 162 an accuracy of 0.01% at room temperature. The thin film sensor's electrical resistance  $(R_S)$  has an initial value at the selected temperature labelled as  $R_{init}$ .  $R_{v}$  is a variable resistor set using a 163 precision resistance decade box from Guildline Instruments model  $9346/10k\Omega$  with a resolution of 164 165 0.01  $\Omega$ , used to balance the bridge ( $R_{v=}R_{init}$ ). A Voltcraft-655 BT multimeter with a sampling frequency of 64 Hz and a measuring range of 10 mV was used to acquire the unbalanced DC voltage 166  $\Delta V$  (between V<sub>a</sub> and V<sub>b</sub>). 167

**Measurement protocol.** A syringe pump (Fisherbrand<sup>TM</sup> KDS100) is used to inject the fluid sample inside the microreactor. The liquids are fed to the microdevice at a flowrate of 10  $\mu$ L/s with steps of 200  $\mu$ L injection per measurement. Apart from these flushes, the fluid in the micro-pool remains static inside the microdevice. Once the fluid is loaded inside the microchamber, the relay is switched to the bridge. The Wheatstone bridge is initially balanced under a negligible current (<1.0 mA) to avoid any sensor's heating, the voltage measured has to be maintained around zero, which corresponds to the  $R_{init}$  of the sensor.

The thin metallic spiral is used as a Joule heating element. However, depending on the sensor's  $R_{init}$ , the voltage and current sent must be slightly tuned to ensure that all applied pulses have the same power regardless of the sensors, allowing comparison of each sensor's response. Equation (1), is used to determine the amount of current (*I*, in A) needed to produce a desired power (*P*, in W).

$$I = \sqrt{\frac{P}{R_{init}}} \tag{1}$$

Then, the desired DC power is applied to the sensor. As the temperature increases, the electrical voltage between the bridge's ends changes, and small resistance increments can be measured. The voltage at the bridge end's is measured , and the resistance of the sensor ( $R_s$ ) is deduced from equation (2) [35].

$$\Delta V = \left(\frac{R_s}{R_2 + R_s} - \frac{R_v}{R_1 + R_v}\right) \times V_0$$
(2)

183 Where  $V_0$  is the DC supply voltage.

The temperature of the microsensor is calculated from the resistance measurements using the experimental values of the variation of the platinum resistivity as a function of temperature. For this material, the temperature coefficient of resistance ( $\alpha$ ) was determined experimentally ( $\alpha$  =  $3.01 \times 10^{-3} \pm 0.21 \times 10^{-3} K^{-1}$ ). The use of this coefficient allows to convert the measured electrical resistance into a temperature variation ( $T - T_{ref}$ ) using equation (3) [36].

$$R_s = R_{ref} \left[ 1 + \alpha \left( T - T_{ref} \right) \right] \tag{3}$$

189 Where *T* is the temperature of the sensor,  $R_{ref}$  is the electrical resistance at temperature  $T_{ref}$ . The 190 temperature change of the sensor structure can be plotted as a function of  $\sqrt{t}$ , using equation (4) as 191 already reported by Gustavsson *et al.* and Harris *et al.* [7,37], and a linear fit can be made once the 192 value of  $\Delta T$  reaches the equilibrium.

$$\Delta T(t) = s\sqrt{t} \tag{4}$$

193 When sensor is sufficiently heated its temperature response should approach linearity when plotted 194 versus the square root of time (available in Supporting Information Figure ESI-3-2). The first non-195 linear portion at the beginning of the squared root trend curve, which is attributed to the substrate 196 effect, is ignored in data processing [7]. In the linear part, the slope (s) is related to the Silicon top 197 reference acting as a heat sink. The silicon top material should be thicker than the microchannel 198 depth, so that it acts as a semi-infinite medium during a heating step [5]. This implies that the linear 199 portion of the curves – sensor temperature responses – are anticipated to be parallel regardless of 200the thermal properties of the fluid inside the micro-pool. The measured slopes constant values at the 201 end of each sensor response indicate that the thermal penetration depth is adequate [23], so all 202 uncertainties are eliminated.

#### 203 **3.** Results and discussion

We report hereafter the experimental results obtained using the micro-sensor implemented within the microfluidic device. This section is composed of three parts: first, the calibration of the sensor response to fit the thermal behaviour of well-known fluids mixtures; second, an external validation of the sensor calibration for two fluids; and finally, new experimental values for a biomass by-product for which there is a lack of thermal conductivity data information in the literature.

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# 3.1. Sensor calibration: water/ethanol mixtures.

Several microfluidic devices were produced using the fabrication procedure described in the previous
 section. For each device, the initial electrical resistance of the sensor at room temperature was

measured, and  $R_{init}$  values ranging from 480  $\Omega$  to 620  $\Omega$  were determined, roughly corresponding to 212 the resistance of the thin Pt spirals, which are about 200 ± 20 nm thick. The calibration of the 213 214 microfluidic devices shown below is the result of three separate sensor calibrations, each with three 215 repeatability measurements. The calibration of each sensor was performed using different 216 water/ethanol mixtures for which thermal conductivity  $\lambda$  values are experimentally known. Indeed, 217 the use of these two liquids in mixture that are harmless and easily accessible allows a wide range of liquid  $\lambda$  values to be covered, from 0.180 to 0.603 W/(m.K). The considered volume fractions of 218 219 ethanol in mixtures were as follows: 0% (pure water), 25%, 50%, 75%, and 100% (pure ethanol). Reference  $\lambda$  values were obtained from the literature [38][39], and are reported in Supporting 220 221 Information Table ESI-4-1. Digital signal processing of the sensor response allows time changes in 222 resistance to be expressed as temperature changes, and curve's offsets converted in  $\lambda$  values. 223 Several parameters inherent to the device may be set to improve the accuracy of  $\lambda$  values obtained 224 during experimental measurements. Among them we investigated: (i) the electrical power applied 225 during heating, (ii) the duration of the heating pulse, and (iii) the selection of the time interval for the  $\lambda$  calculation. 226

227 We investigated heating power values from 30mW to 90mW. To ensure that all sensors deliver the same heating power during the pulse, the electrical current is adapted by considering equation (1) 228 229 together with the determined sensor  $R_{init}$  value. In practice, we can assume that the sensor's 230 accuracy increases with heating power. However, applying too much heating power may result in 231 disadvantages such as local vaporization of the liquid and bubble formation, or even sensor failure. Indeed, the risk of the sensor deteriorating and being damaged increases above 60 mW. Figure 3 232 shows the temperature response curves obtained for the considered water/ethanol mixtures, 233 234 applying a heating power of 60 mW. Curves for other investigated heating powers are available in 235 Supporting Information Figures of section ESI-4. Note that a heating power of 30mW was found not 236 sufficient to distinguish between some of the water/ethanol mixtures and did not lead to proper 237 similar slopes for all of them. At 40 mW, it resulted in different offsets for mixtures, but different slopes were still observed. At 50 mW, slopes became similar and useable for the  $\lambda$  calculation. For our proposed microfluidic sensor device, we determined that a heating power of 60 mW (60.03 ± 0.42 mW) is appropriate and was therefore considered for the measurements, unless specified otherwise.

The duration of the heat pulses must be chosen to ensure that the thermal energy reaches the limits 242 of the static fluid sample within the microcavity. In practice, it could be considered that accuracy 243 244 improves with pulse duration. However, after a certain period, the temperature of the fluid does not 245 rise as much because the silicon top reference, dissipates the heat acting as heat sink. We investigated heating pulse durations from 15 s to 60 s. Figure 3 shows the temperature response 246 247 curves for the water/ethanol mixtures applying a heating pulse of 60 s. Clearly, a heat pulse greater than 12 s (corresponding to  $3.5 \text{ s}^{1/2}$  on Figure 3) appears mandatory, which means that for shorter 248 249 measurement times, the heat flow has not covered the distance between the heater and the silicon 250 substrate (59.8 µm). To have a sufficient integration period for data treatment with the proposed 251 microfluidic device, we considered a heat pulse duration of 60 s was appropriate and this value will be used hereafter, unless specified otherwise. 252



Figure 3: Time variations of the temperature in the microcavity filled with water/ethanol mixtures, when a heat pulse (60 mW during 60 s) is applied to the heater/sensor. A, B, and C stand for three

#### different intervals each having a 16 s duration.

253 The time interval of the curve used to derive temperature variations which are then related to  $\lambda$ 254 values must be carefully fixed. In practice, it can be assumed that the greater the time interval (close 255 to the end of the curve), the greater the accuracy. However, the local slope of the curve decreases with time along with the  $\Delta T$  values. Linear regressions were performed on the obtained temperature 256 response curves for the water/ethanol mixtures (Figure 3), over subsets of the time interval [ $3.5 \text{ s}^{1/2}$ 257 ; 7.7 s<sup>1/2</sup>]: the time interval was divided into three, each having a duration of 16 s, *i.e.*, A: [3.5 s<sup>1/2</sup>; 258 5.3 s<sup>1/2</sup>], B: [5.3 s<sup>1/2</sup>; 6.6 s<sup>1/2</sup>], and C: [6.6 s<sup>1/2</sup>; 7.7 s<sup>1/2</sup>]. While the slopes obtained for interval A 259 260 are similar across mixtures, these values are about twice as high as those derived for intervals B and 261 C, indicating that heat flux has not yet reached the liquid boundary. In these two latter cases, we 262 found appropriate to use B as the time interval, temperature variations are expected to be greater 263 with B than with C, leading to a better accuracy.

From the curves shown in Figure 3 the offset value from linear regressions performed in the interval B  $[5.3s^{1/2}; 6.6s^{1/2}]$  were extracted and related to the thermal conductivity  $\lambda$  of the corresponding water/ethanol mixtures. Depending on the sensor, the slopes obtained from linear fits at  $[5.3s^{1/2}; 6.6s^{1/2}]$  ranges from 0.028 to 0.035.

Depending on the composition of the water/ethanol mixture, the  $\Delta T$  value caused by a heat pulse 268 ranges from 1.9 K to 2.5 K. In the investigated time interval, the variation of the offset values with 269 thermal conductivities can be assumed as a linear model ( $R^2 = 0.992$ ) with offset = a. $\lambda$  + b. The a and 270 b values obtained for each sensor are reported in Supporting Information Table ESI-5-1. The so-271 272 obtained expression stands for the calibration curve available in Supporting Information Figure ESI-5-273 1. Note that Oudebrouckx et al. suggested the use of an exponential relation between the 274 temperature offset and  $\lambda$ . However, such fitting curves are not adapted to our microfluidic device and operating conditions. Moreover, the use of a linear relation between the offset and  $\lambda$  makes the 275

276 uncertainty on the determination of  $\lambda$  constant over the whole range. Finally, it should be noticed 277 that due to the variability of the parameters a and b among sensors, it is not possible to establish a 278 universal curve applicable to all sensors.

279

#### **3.2.** Sensor calibration: external validation.

Two fluids with known experimental thermal conductivity behaviours were selected to perform the validation of the microfluidic device, i.e. fluids not used to set the calibration curve. First an hydrocarbon, n-pentadecane having at 293.15 K a  $\lambda$  value of 0.137 W/(m.K), slightly outside of the calibration curve. The results obtained for this fluid should lead to conclusions about extrapolations from the calibration curve. Then, an oxygenated fluid, ethan-1,2-diol having at 293.15 K a  $\lambda$  value of 0.255 W/(m.K), which is within the calibration curve's range, but with a more pronounced non-linear trend in  $\lambda$  with temperature variations than other fluids.

For each fluid, measurements were performed using the three sensors and then, the  $\lambda$  values were 287 288 determined by applying the corresponding calibration curve. Values of  $\lambda$  measured for n-289 pentadecane and ethan-1,2-diol at 293.15 K are detailed in the Supporting Information Table ESI-5-2. 290 For n-pentadecane, the values obtained for  $\lambda$  range between 0.128 and 0.138 with a mean value of 291 0.134 W/(m.K). This latter is in good agreement with the reference experimental value of 0.137 292 W/(m.K) [40]. This external validation point demonstrates that calibration curves can be extrapolated 293 to  $\lambda$  values lower – or higher offset values – than the range covered by water/ethanol mixtures. For 294 ethan-1,2-diol, the  $\lambda$  measured values range between 0.290 and 0.316 with a mean value of 0.303 W/(m.K). The observed systematic deviation of about 20% from the reference experimental value of 295 0.255 W/(m.K) [41] is unsatisfactory and appear to be similar to data from the DIPPR database [42] 296 297 that was not considered for correlations settings. Searching for artefacts inherent to our 298 experiments, we investigated property correlations [43] and properties differences between ethan-299 1,2-diol and other fluids considered in this work. It highlighted dissimilarities primarily in viscosity, for instance the value for ethan-1,2-diol (21 mPa.s) is about one order of magnitude higher than the 300 301 value for water (1.0 mPa.s), ethanol (1.2 mPa.s), and n-pentadecane (2.5 mPa.s), at 293.15 K [42,43]. This would suggest that heat transfer by convection is not so negligible in microfluidics, and in our case,  $\lambda$  measurements are accurate for the range of viscosity values covered by fluids used during calibration.

The variation of  $\lambda$  with the temperature was then investigated for n-pentadecane and ethan-1,2-diol. 305 The obtained values are presented in Table 1 and Figure 4 compares the obtained values to those 306 307 suggested by the literature [40–43]. For n-pentadecane, the good agreement observed with respect to reference  $\lambda$  values at 293.15 K are confirmed at 313.15 and 333.15 K, with a mean absolute 308 309 relative deviation of about 8%. This validates the ability of our microfluidics device as well as our approach to be used to quantitatively predict the  $\lambda$  of liquids. Regarding ethan-1,2-diol, similarly to 310 311 observations done at 293.15 K, our measured  $\lambda$  values overestimate reference values at 313.15 and 333.15 K. It can be noticed that the trend observed with temperature variations - ranging from 312 313 293.15 and 333.15 K – agrees with that of the reference values.

314 Table 1: Thermal conductivity (W/(m.K)) values measured for the n-pentadecane and ethan-1,2-diol using our

315

microfluidic device, for temperature ranging from 293.15 to 333.15 K.

	n-pentadecane	ethan-1,2-diol
293.15 K	0.134 ± 0.019	0.303 ± 0.028
313.15 K	0.125± 0.024	0.303 ± 0.027
333.15 K	0.111 ± 0.026	0.305 ± 0.027

316



Figure 4: The evolution of  $\lambda$  value as a function of temperature for n-pentadecane (blue) and ethan-1,2-diol (black). Experimental values obtained in this work for n-pentadecane (triangles) and ethan-1,2-diol (circles)

are compared to predictions using DIPPR's correlations (dashed lines).

## **317 3.3.** Thermal conductivity data for 2,5-dimethylfuran.

The biomass can be seen as a raw material from which high-value products can be derived. For 318 instance, cellulose present in lignocellulosic biomass can be converted into glucose or fructose, from 319 320 which compounds with potential as biofuels can be derived, e.g. 2,5-dimethylfuran. To our 321 knowledge, there is no experimental  $\lambda$  data for 2,5-dimethylfuran. Therefore, we used our 322 microfluidic device to generate new data points, and each data point is the average result of 10 acquisitions.  $\lambda$  values measured for 2,5-dimethylfuran at 293.15, 313.15 and 333.15 K are reported in 323 324 Table 2. Indeed, its viscosity value of 0.4 mPa.s at 293.15 K [49,50] is similar to that of fluids used to 325 during sensors calibrations.

Figure 5 shows a comparison between our data points and the predicted evolutions of the  $\lambda$  value as a function of temperature for 2,5-dimethylfuran using two models: one available from the DIPPR [42] and one proposed by Chung *et al.* [44]. It can be noticed that the two predictive models overestimate our experimental data, and that the trends observed with temperature – ranging from 293.15 to 333.15 K – reasonably agree. Based on our experimental data and temperature ranges, we can suggest the use of a linear model to estimate the thermal conductivity 2,5-dimethylfuran as a function of temperature, as follow:

333

$$\lambda = -4.25 \times 10^{-4} \text{ T} + 0.24542,$$

334 with T the temperature.

335 Table 2: Thermal conductivity (W/(m.K)) values measured for 2,5-dimethylfuran at 293.15, 313.15 and 333.15 K.

<λ>	293.15 K	313.15 K	333.15 K
λ	0.120 ± 0.018	0.114 ± 0.015	0.103 ± 0.021

336



Figure 5: The evolution of  $\lambda$  value as a function of temperature for 2,5-dimethylfuran. Experimental values from this work are compared to predictions using DIPPR's correlations (dashed line) and the model by Chung et al. [44] (dotted line).

#### 337 **4. Conclusion**

338 We investigated the use of materials commonly employed for microfluidic reactors compatible with 339 harsh processes conditions to develop a new microdevice for  $\lambda$  measurements, with an operating principle based on the transient thermal offset approach. The microfluidics device, including a sensor 340 341 integrated into a microchannel, was fabricated following a three-step procedure: microfluidic channels were etched on a silicon substrate using photolithography / wet etching techniques; 342 sensors were created on a borosilicate glass substrate surface by depositing a spiral shaped metal 343 344 thin film; the silicon and borosilicate glass substrates were assembled using a fusion bonding process. 345 The sensor response was calibrated by fitting the thermal behaviours of well-known water/ethanol mixtures. We decided to set the heating power, the length of the heating pulse, and the time interval 346 for  $\lambda$  calculations to 60mW, 60 s and [28 s; 44 s], respectively. The microfluidic device and its settings 347 were then externally validated on two fluids: n-pentadecane and ethan-1,2-diol, for temperatures 348 ranging from 293.15 to 333.15 K. Finally, we generated new experimental  $\lambda$  values for 2,5-349 dimethylfuran. 350

We demonstrated that existing thermal conductivity measurement devices can be miniaturized, by considering microfluidic procedures and using silicon as heat sink on one side/surface of the micro-

353 chip. The manufactured microdevice enables to carry out experiments under high pressure and 354 temperature conditions. Besides the use of inert materials such as silicon and borosilicate open ways to measure thermal conductivity values for various chemical families and to allow direct observation 355 356 of fluids, which is of interest for coupling measurements with other in situ characterizations 357 techniques. We investigated the temperature effect on thermal conductivity for fluids containing 358 hydrocarbons and oxygenated compounds. Future works will examine pressure effects on the  $\lambda$  of 359 liquids given that the silicon/borosilicate technology can be used in a wide range of pressure and 360 temperature conditions. Considering that these effects are generally negligible for pressures below 361 about 50 bar [45], the microdevice – and more specifically the measurement micro-cavity – will have 362 to be redesigned to withstand pressures well above this limit. Since the proposed design places the sensor in direct contact with the fluid, the future deposition of thin protective films made of inert 363 364 glasses on top of the sensors could open ways to expand this approach to more aggressive chemicals. 365

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